

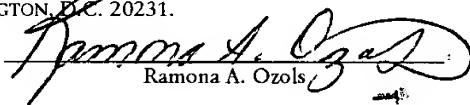
2874
#51390
PATENT US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	MIKE E. HAMERLY	Group Art Unit:	2874
Serial No.:	09/771,757	Docket No.	56132USA9A
Filed:	January 29, 2001		
For:	OPTICAL SWITCH BASED ON ROTATING VERTICAL MICRO-MIRROR		

U.S. PATENT & TRADEMARK OFFICE
JAN 11 2002
Commissioner for Patents
Washington, D.C. 20231

I CERTIFY THAT, ON NOVEMBER 30, 2001, THIS PAPER IS BEING
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Ramona A. Ozols

INFORMATION DISCLOSURE STATEMENT

In compliance with the duty imposed by 37 C.F.R. 1.56, and in accordance with C.F.R. sections 1.97 *et seq.*, the materials enclosed herewith are brought to the attention of the Examiner as possibly being of interest in connection with the above-identified patent application. Consideration of each of the documents listed on the attached 1449 form(s) is respectfully requested. The filing of this information disclosure statement shall not be construed to be an admission that the information cited in the statement is, or is construed to be, prior art to the present application. Pursuant to the provisions of M.P.E.P. 609, Applicants further request that a copy of the 1449 form(s), marked as being considered and initialed by the Examiner, be returned with the next Official Communication.

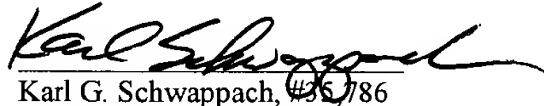
No fee is deemed necessary for the entry of this Information Disclosure Statement. Should any fee be required, the Commissioner is authorized to charge our Deposit Account No. 06-0029 and notify us of the same.

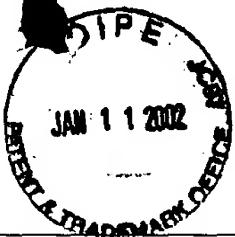
Respectfully Submitted,

Dated: November 30, 2001

BILL L. WEAVER et al.

By:


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November 30, 2001
Page 1 of 1

Form PTO-1449 U.S. Department of Commerce Patent and Trademark Office		Atty. Docket No.	Serial No.
		56132USA9A	09/771,757
		Applicant	
		MIKE E. HAMERLY	
		Filing Date	Group
		January 29, 2001	2874
INFORMATION DISCLOSURE STATEMENT BY APPLICANT			

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS						
Name	Document Number	Date MM/DD/YY	Country	Class	Subclass	Translation Yes/No
BuH	41 00 358 A1	07/09/1992	DE	385	15X	No

OTHER PRIOR ART-NON PATENT LITERATURE DOCUMENTS
(Including Author, Title, Date, Pertinent Pages, Etc.)

 	<p>Reid et al., "A Surface Micromachined Rotating Micro-Mirror Normal to the Substrate", IEEE Conference on Optical MEMS, pp. 39-40 (1996).</p> <p>Comtois et al., "Applications for Surface-Micromachined Polysilicon Thermal Actuators and Arrays", 58 Sensors and Actuators 19-25 (1997).</p>
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.